



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No. 277/013

In re patent application of

Kyu-Dong JUNG, et al.

Group Art Unit: 2813

Serial No. 10/701,552

Examiner: Monica D. Harrison

Filed: November 6, 2003

*Confirmation No.: 8318*

For: METHOD AND APPARATUS FOR VACUUM-MOUNTING A  
MICRO-ELECTRO MECHANICAL SYSTEM ON A SUBSTRATE

**AMENDMENT UNDER 37 C.F.R. §1.111**

Mail Stop Amendments  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Va. 22313-1450

Sir:

In response to the Office action mailed June 14, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

**Amendments to the Specification** being on page 2 of this paper.

**Amendments to the claims** are reflected in the listing of the claims, which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.